

<b>LIST OF ART CITED BY APPLICANT</b> <b>(PTO-1449)</b>				ATTY. DOCKET NO. <b>YHK-0123</b>	APPLN. SERIAL NO. <b>10/743,782</b>	
				APPLICANT(S) <b>Hun Gun PARK, Jae Hong LEE, Seok Dong KANG and Tae Su HWANG</b>		
				FILING DATE <b>December 24, 2003</b>	GROUP <b>2889</b>	
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>						
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	
<b>U.S. PATENT APPLICATIONS</b>						
	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS	
<b>FOREIGN PATENT DOCUMENTS</b>						
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
	JP 2001-216903	08/10/2001	Japan (English Abstract and Japanese Full Text)			<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)</b>						
	Japanese Office Action dated May 13, 2008.					
EXAMINER	/Hana Sanei/			DATE CONSIDERED		
						10/01/2008

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.